

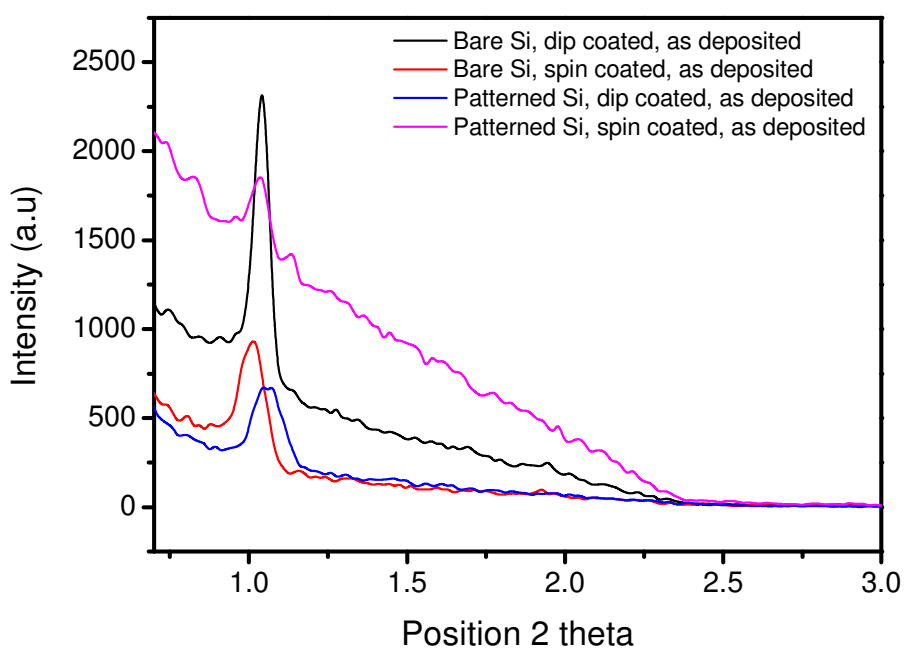
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# Pore Directionality and Correlation Lengths of Mesoporous Silica Channels Aligned by Physical Epitaxy

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**Figure S1** Reflective X-ray Diffraction patterns of spin- and dip-coated mesoporous films on bare and patterned silicon substrates